



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shohei FUJISAWA

Group Art Unit: 2879

Application No.: 10/849,880

Examiner: P. MACCHIAROLO

Filed: May 21, 2004

Docket No.: 119822

For: LIGHT SOURCE UNIT, METHOD OF MANUFACTURING LIGHT SOURCE
UNIT, AND PROJECTOR

SUBMISSION OF REFERENCES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the attached references be placed in the Patent Office file regarding the above-identified application. The references were cited in a Communication from the Japanese Patent Office prior to payment of the Issue Fee.

1. JP U 03-057802.
Published June 4, 1991.
2. JP U 63-008707.
Published on January 21, 1988.

Respectfully submitted,

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JAO:KDB/mab
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